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ATMI-668

APR 27 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:)	Docket No.:	ATMI-668 (7493)
Applicants:)	Conf. No.:	4823
Application No.:)	Art Unit:	1752
Date Filed:)	Examiner:	LE, Hoa Van
Title:)	Customer No.:	25559
COMPOSITION AND)		
PROCESS FOR POST-ETCH)		
REMOVAL OF)		
PHOTORESIST AND/OR)		
SACRIFICIAL ANTI-)		
REFLECTIVE MATERIAL)		
DEPOSITED ON A)		
SUBSTRATE)		

FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Hoa V. LE

Fax No. (703) 872-9306

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Number of Pages (including cover)

Insta A. Fr

Tristan A. Fuierer

April 27, 2005

Date _____

**RESPONSE TO RESTRICTION REQUIREMENT IN APRIL 18, 2005 OFFICE ACTION
IN U.S. PATENT APPLICATION NO. 10/792,038**

**Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450**

Sir: